



PATENT

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANTS : Ming Gao YAO et al.  
SERIAL NO. : 10/763,727  
FILED : January 23, 2004  
FOR : SYSTEM AND METHOD FOR PREVENTING OPERATIONAL  
AND MANUFACTURING IMPERFECTIONS IN  
PIEZOELECTRIC MICRO-ACTUATORS  
GROUP ART UNIT : 2652  
EXAMINER : Craig A. RENNER

M/S: AMENDMENTS  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: M/S: AMENDMENTS, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on	
Dated: February 28, 2005	Signature: <u>Barbara Vance</u>
Barbara Vance	

**AMENDMENT AND RESPONSE**

Dear Sir:

The following remarks below are respectfully submitted in response to the Office Action dated November 30, 2004.

**Amendments to the Specification** begin on page 2 of this paper.

**Amendments to the Abstract** begin on page 4 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begin on page 5 of this paper.

**Amendments to the Drawings** begin on page 8 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.

An **Appendix** including the amended drawings is attached following page 12 of this paper.